



FTW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

ITOH ET AL.

Atty. Ref.: 1035-646; Confirmation No. 4549

Appl. No. 10/589,003

TC/A.U. 2812

Filed: August 10, 2006

Examiner: Jae LEE

For: GROUP I-VII SEMICONDUCTOR SINGLE CRYSTAL THIN FILM AND PROCESS
FOR PRODUCING SAME

* * * * *

July 30, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

In response to the Interview Summary, dated July 7, 2009, it is noted that a Statement of the Substance of the Telephone Interview on June 26, 2009, is included in the Amendment filed on July 1, 2009, in response to the outstanding Office Action.

It is again noted that, during the interview, the Examiner and his supervisor indicated that the claims, as set forth in the Amendment filed on July 1, 2009, would overcome the rejection under 35 U.S.C. 112 and would distinguish over the cited references and thus overcome the rejection under 35 U.S.C. 103(a) in the Office Action of April 2, 2009. The Examiner also

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indicated that the allowance of the amended claims would be subject to an additional search after the filing of the Amendment.

Respectfully submitted,

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